

Application Data Sheet

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Application Information

Title Line One: METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE (AS AMENDED)
Total Drawing Sheets: 5
Formal Drawings?: yes
Application Type: Utility
Docket Number: 492322006510

Representative Information

Representative Customer Number: 25227

Prior Foreign Applications

This Application is a Disional of:

Application Number: 10/215,188
Filing Date: August 9, 2002

Prior Foreign Application One: 2001-243725
Filing Date: August 10, 2001
Country: Japan
Priority Claimed: yes